

Confirmation No. 3317

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	Detechevery, Celine	Examiner:	Baisa, Joselito
Serial No.:	10/564,582	Group Art Unit:	2832
Filed:	January 12, 2006	Docket No.:	NL030878US
Title:	INDUCTIVE AND CAPACITIVE ELEMENTS FOR SEMICONDUCTOR TECHNOLOGIES WITH MINIMUM PATTERN DENSITY REQUIREMENTS		

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**NOTICE OF APPEAL UNDER 37 C.F.R. § 41.31**

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

This is a Notice of Appeal for the above-referenced application.

Please charge Deposit Account No. 50-0996 (NXPS.267PA) in the amount of \$510.00 for the large-entity fee required by Rule 41.20(b)(1) and pursuant to the Consolidated Appropriations Act, 2005, signed on December 8, 2004. Also, please charge/credit the same account for any additional fees/overages.

Presented for appeal are claims 1-22.

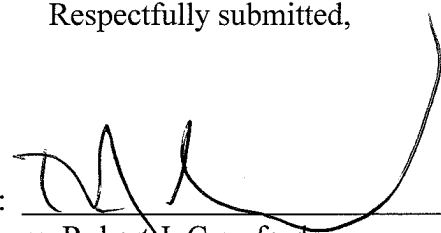
The undersigned is of record and with authority to prosecute the appeal on behalf of the Assignee.

Respectfully submitted,

*Please direct all correspondence to:*

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